

FIG.1A

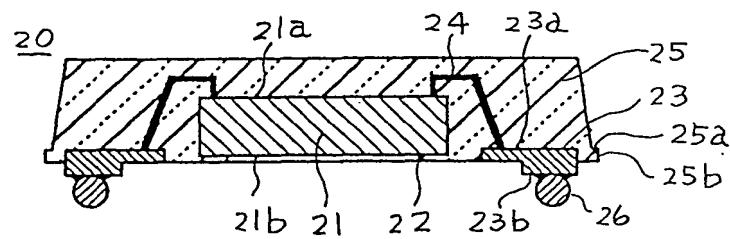
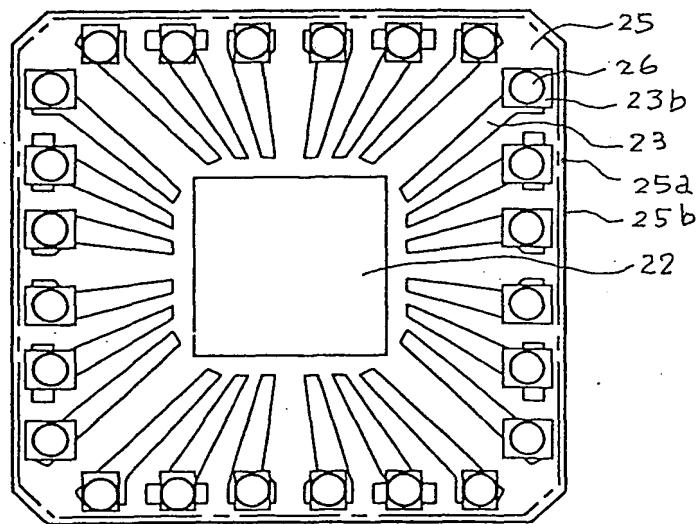


FIG.1B



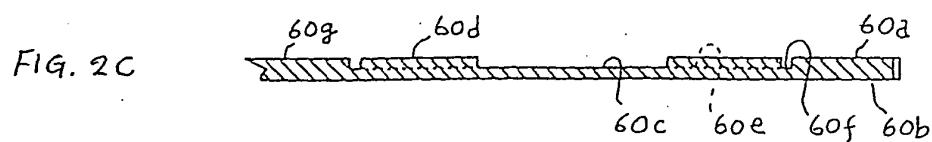
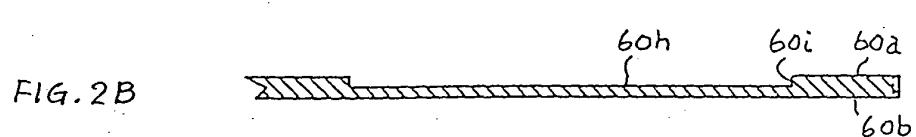
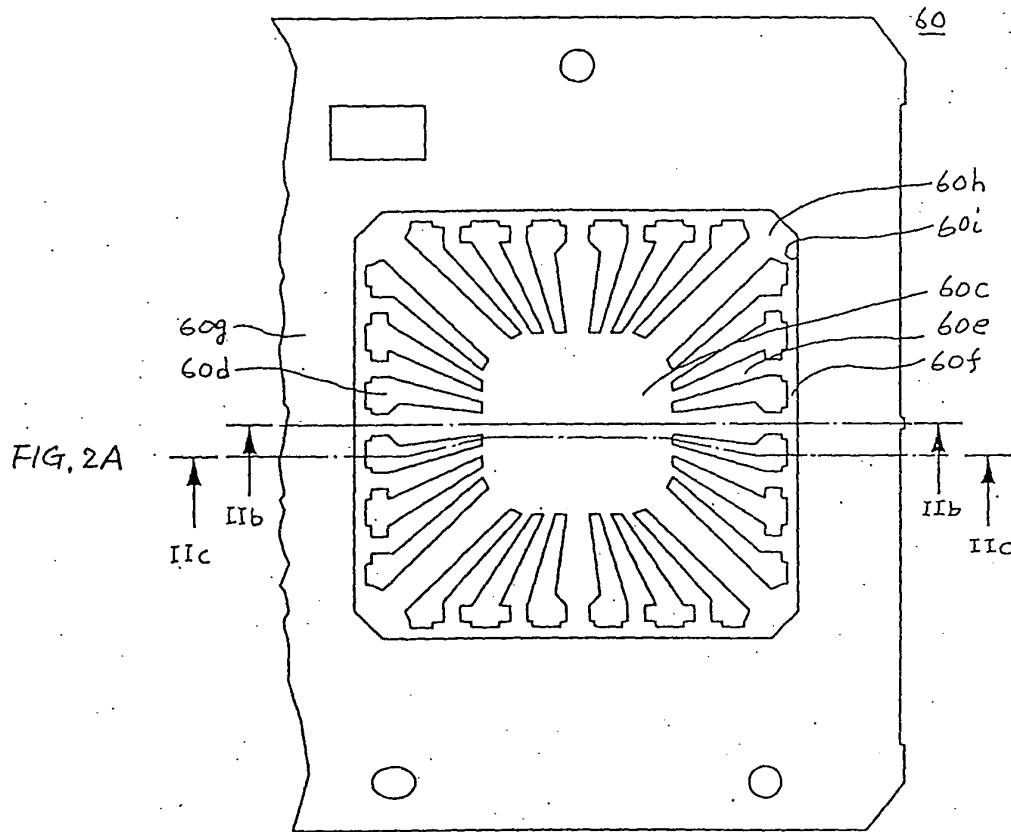


FIG. 3A

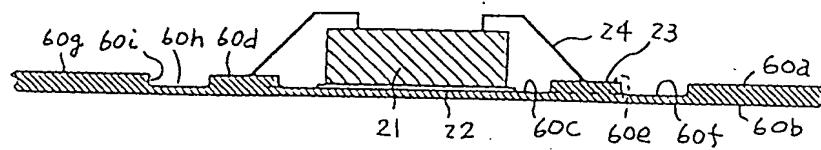


FIG. 3B

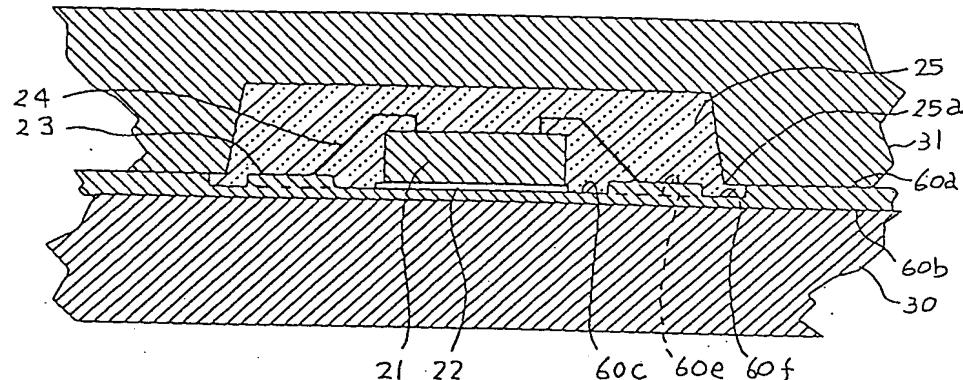


FIG. 3C

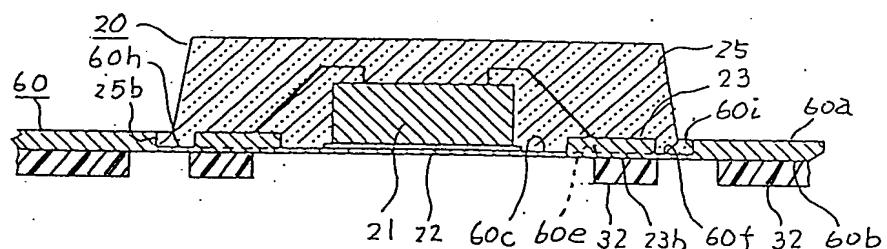


FIG. 3D

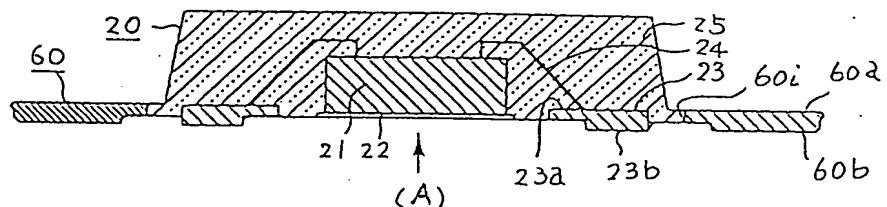


FIG. 3E

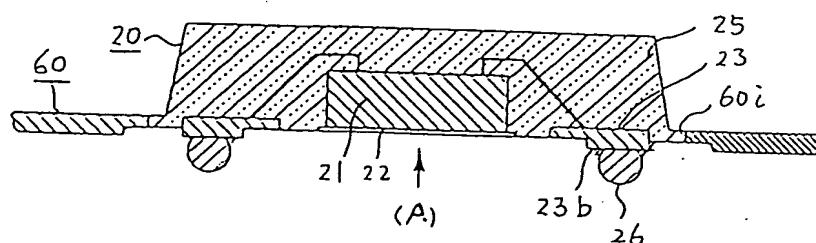


FIG. 4A

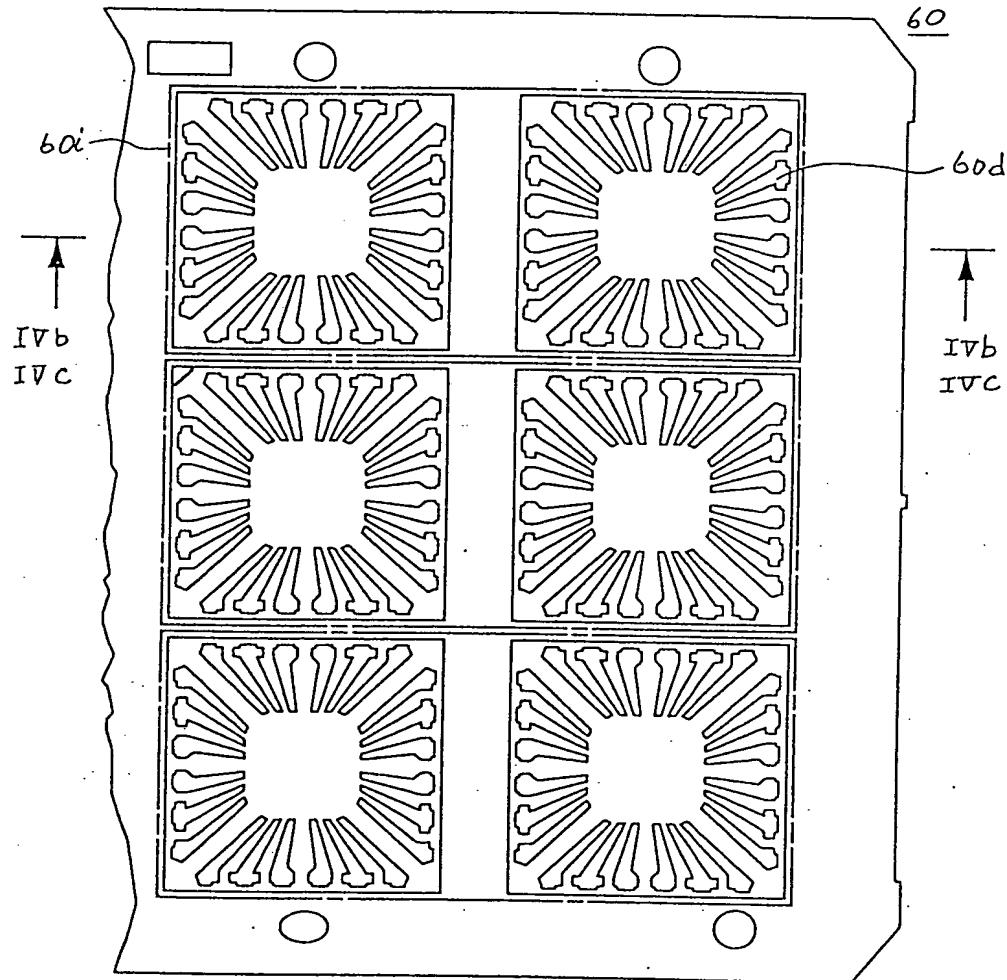


FIG. 4B

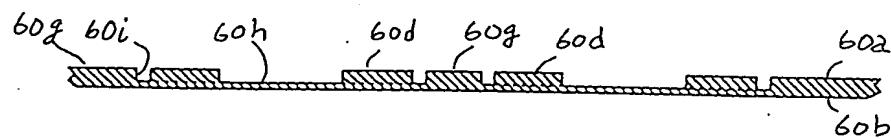
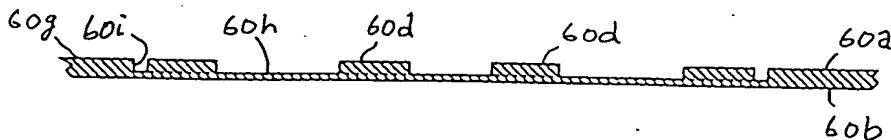
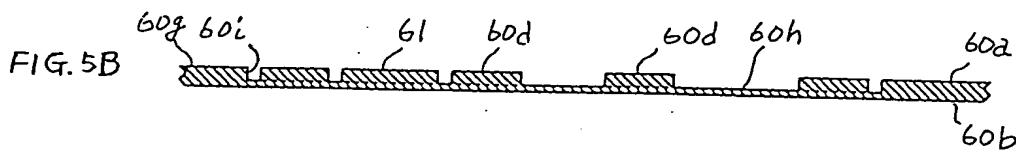
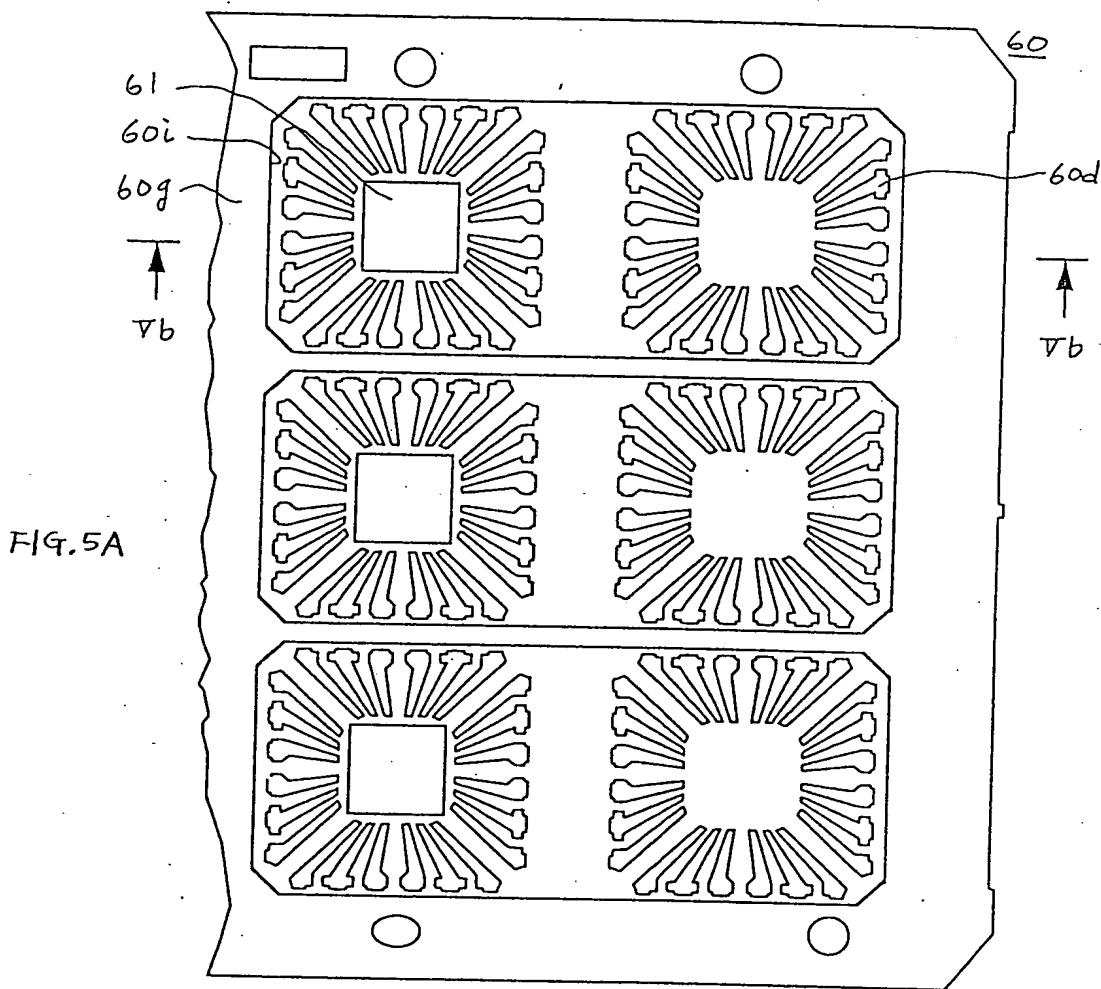


FIG. 4C





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FIG.6

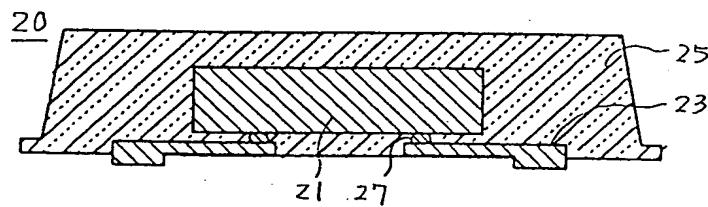


FIG.7

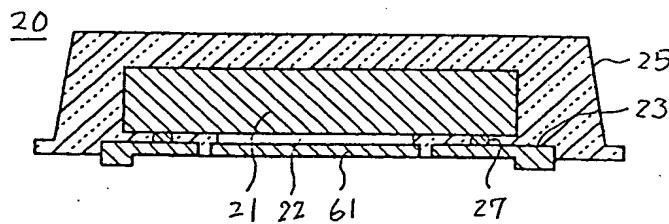


FIG. 8A

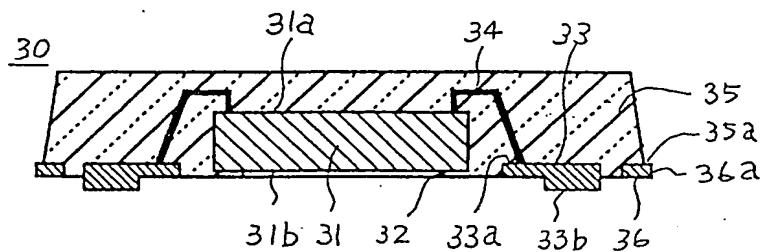
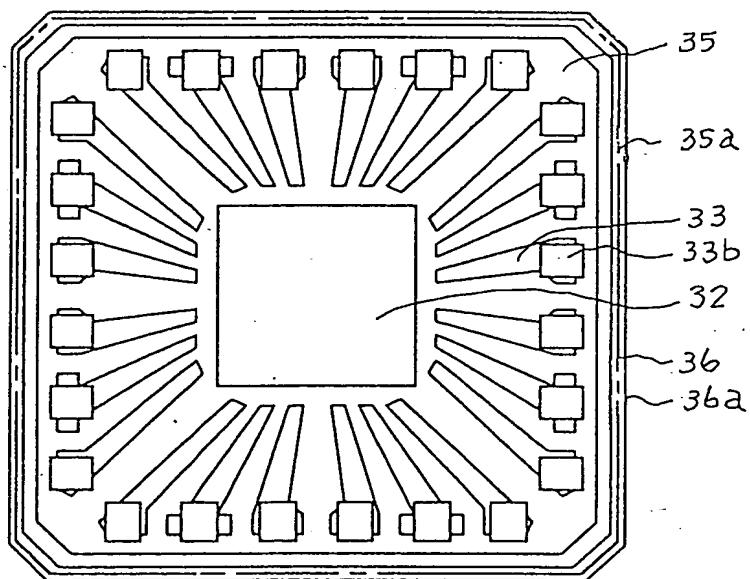


FIG. 8B



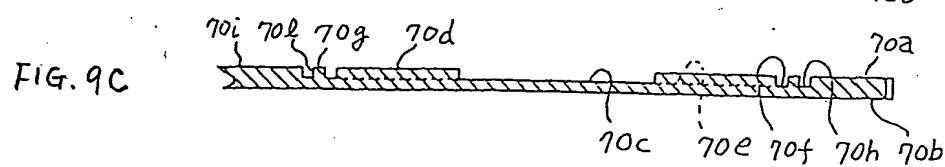
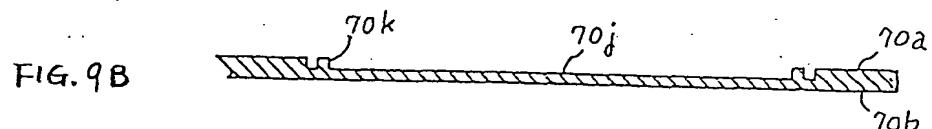
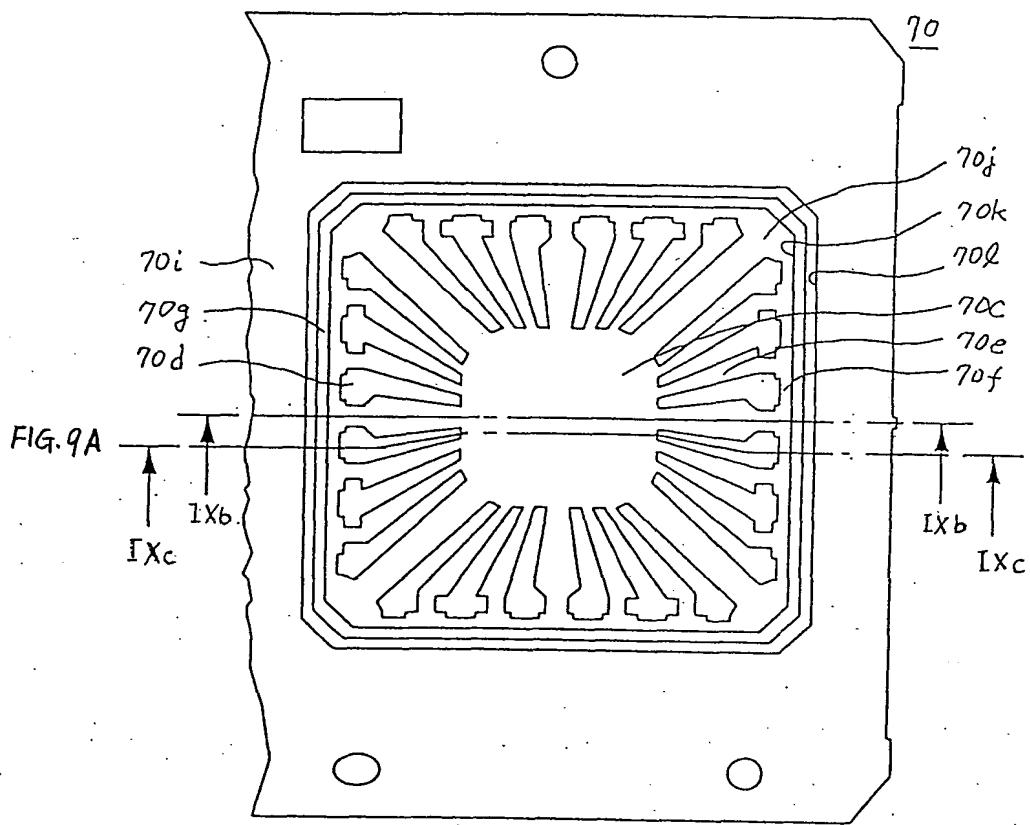


FIG. 10A

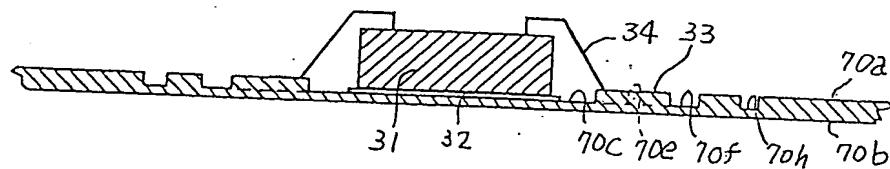


FIG. 10B

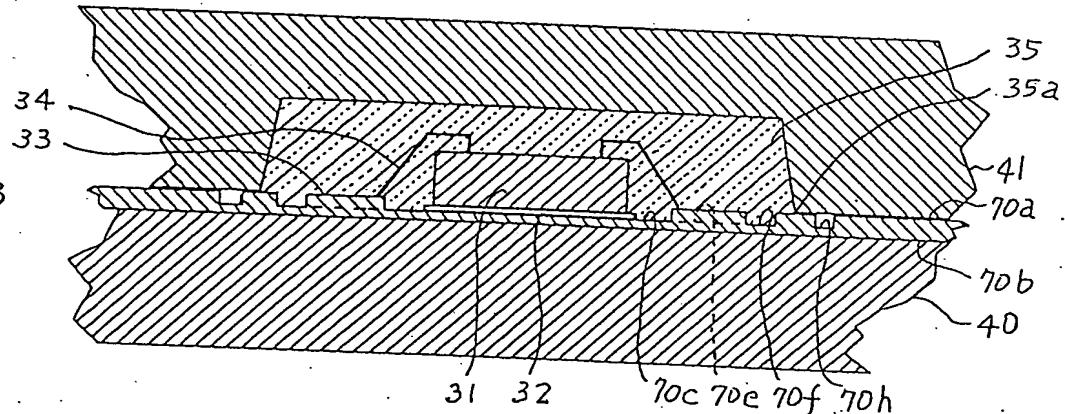


FIG. 10C

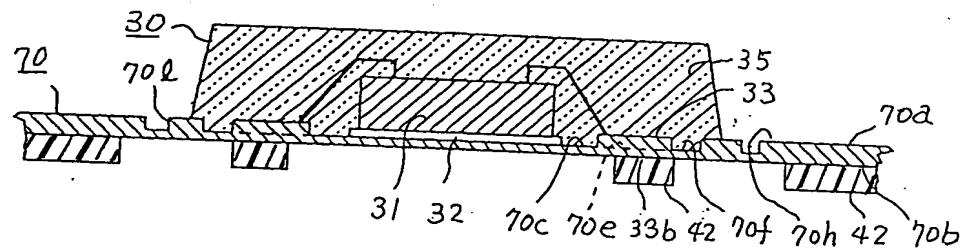
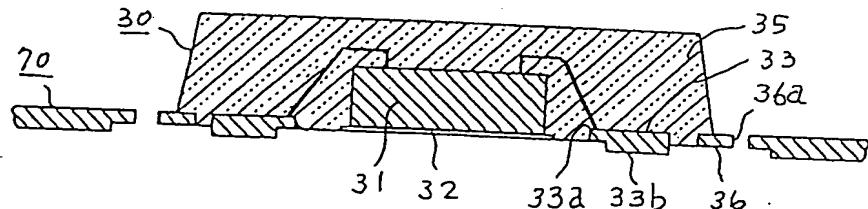


FIG. 10D



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FIG. 11A

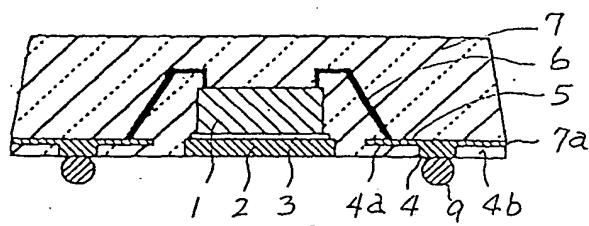
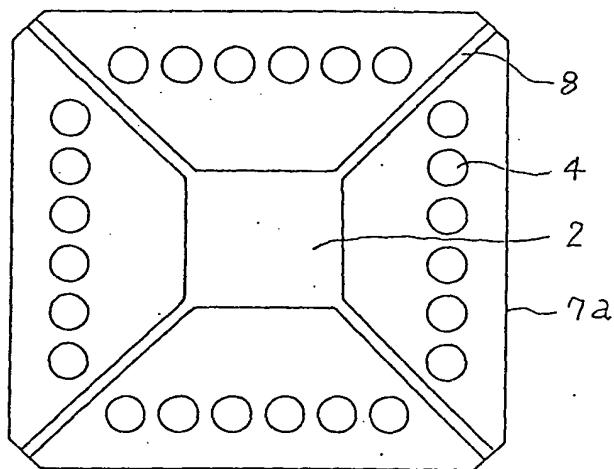
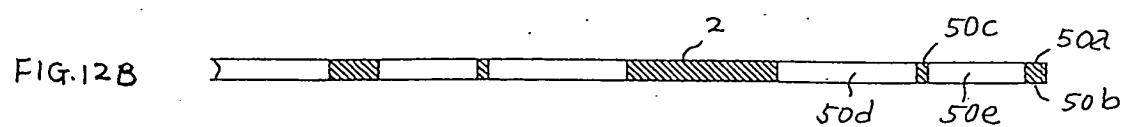
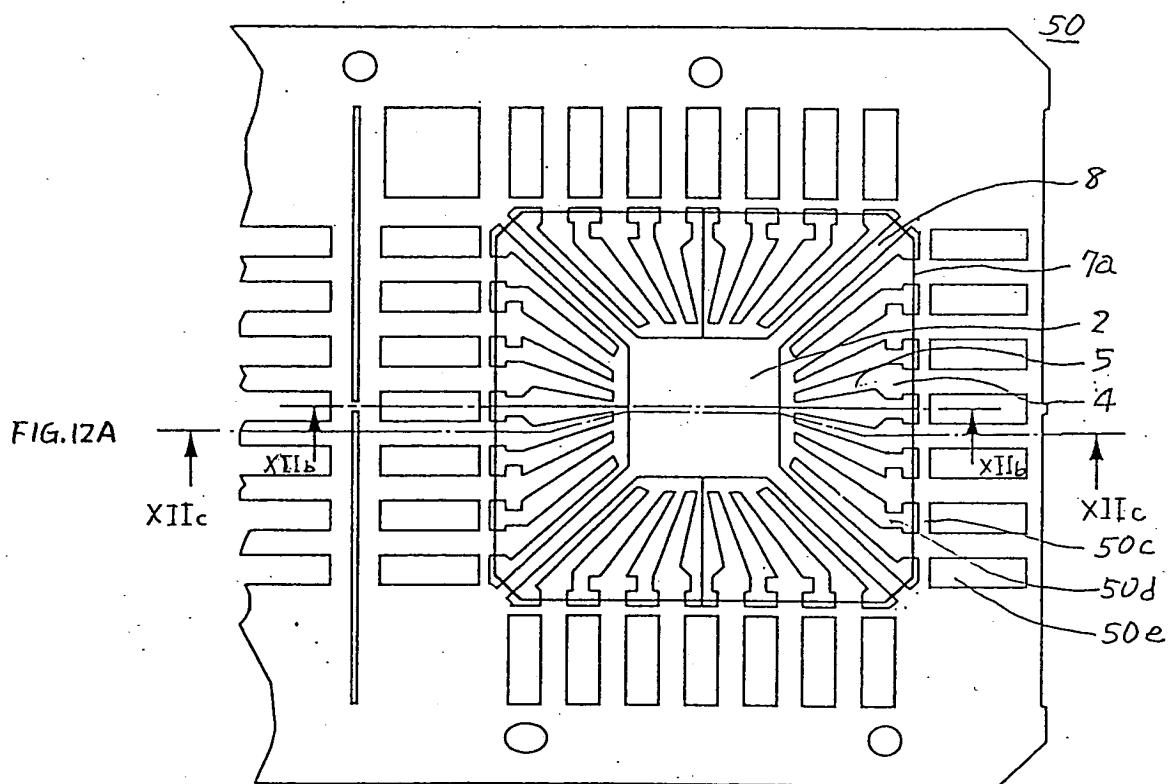


FIG. 11B





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FIG.13A



FIG.13B

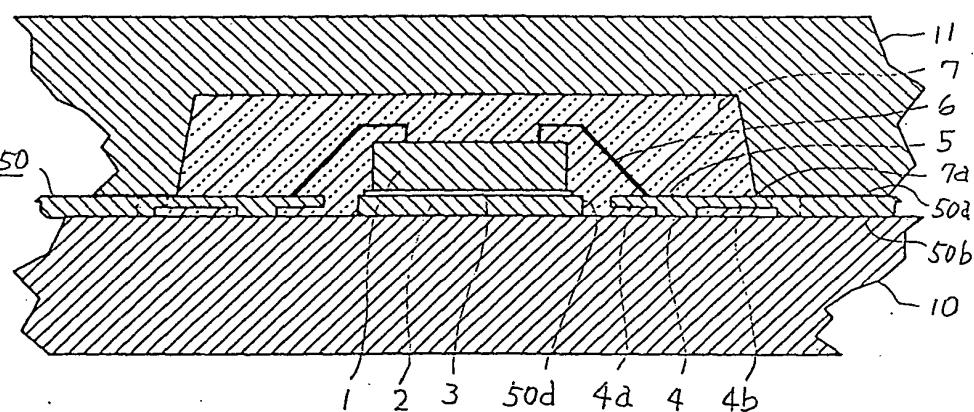


FIG.13C

